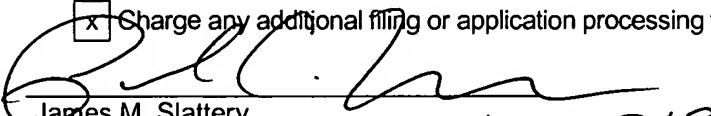


FFW

AMENDMENT TRANSMITTAL LETTER				Docket No. 4249-0112P	
Application No. 10/680,229-Conf. #5826		Filing Date October 8, 2003		Examiner B. K. Talbot	
				Art Unit 1792	
Applicant(s): Kui YAO et al.					
Invention: METHOD TO PRODUCE A RELIABLE PIEZOELECTRIC THICK FILM ON A SUBSTRATE					
<b>MS Amendment</b> Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	23	- 38 =	0	x 52.00	0.00
Independent Claims	1	- 3 =	0	x 220.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 James M. Slattery Attorney Reg. No.: 28,380 BIRCH, STEWART, KOLASCH & BIRCH, LLP				Dated: <u>January 6, 2009</u>	

*f6* *#43,368*



Docket No.: 4249-0112P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Kui YAO et al.

Application No.: 10/680,229

Confirmation No.: 5826

Filed: October 8, 2003

Art Unit: 1792

For: METHOD TO PRODUCE A RELIABLE  
PIEZOELECTRIC THICK FILM ON A  
SUBSTRATE

Examiner: Talbot, Brian K.

**REQUEST FOR RECONSIDERATION**

**REPLY UNDER 37 C.F.R. 1.111**

**MS Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**January 6, 2009**

Sir:

In response to the Non-Final Office Action mailed October 10, 2008, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes

**Listing of Pending Claims (No Changes) and  
Remarks.**